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**PATENT**

**UNITED STATES PATENT AND TRADEMARK OFFICE**

Application No.: 10/797,046                      Group Art Unit: 2811  
Filing Date: March 11, 2004                      Examiner: Ori Nadav  
Applicant: Jung-Hyun LEE et al.  
Title: METHOD FOR MANUFACTURING OXIDE FILM HAVING HIGH  
DIELECTRIC CONSTANT, CAPACITOR HAVING DIELECTRIC FILM  
FORMED USING THE METHOD, AND METHOD FOR  
MANUFACTURING THE SAME  
Attorney Docket: 2557SI-001239/US

Customer Service Window  
Randolph Building  
401 Dulany Street  
Alexandria, VA 22314  
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April 16, 2010

OK TO ENTER: /O.N./

**AMENDMENT UNDER 37 C.F.R. §1.116**

Sir:

In response to the Final Office Action mailed February 16, 2010, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

**Amendments to the Claims** begin on page 2 of this Amendment.

**Remarks** begin on page 3 of this Amendment.

	Claims remaining after Amendment		Highest number previously paid for		Present extra
<b>Total</b>	2	-	20	=	0
<b>Independent</b>	1	-	3	=	0